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Soft X-rays spectroscopy with a commercial CMOS image sensor at room temperature

Miguel Sofo Haro^{a,c,*}, Fabricio Alcalde Bessia^{b,c}, Martín Pérez^{a,c}, Juan Jerónimo Blostein^{b,c}, Darío Federico Balmaceda^c, Mariano Gomez Berisso^{b,c}, José Lipovetzky^{a,b,c}

^aComisión Nacional de Energía Atómica (CNEA), Centro Atómico Bariloche (CAB), Argentina.

^bConsejo Nacional de Investigaciones Científicas y Técnicas (CONICET), Argentina.

^cInstituto Balseiro, Universidad Nacional de Cuyo, Argentina

Abstract

Besides their application in point and shoot cameras, webcams, and cell phones, it has been shown that CMOS image sensors (CIS) can be used for dosimetry, X-ray and neutron imaging applications. In this work we will discuss the application of an ON Semiconductor MT9M001 CIS, in low energy X-ray spectroscopy. The device is a monochromatic front-side illuminated sensor, very popular in consumer electronics. In this work we introduce the configuration selected for the mentioned sensor, the image processing techniques and event selection criteria, implemented in order to measure the X-ray energy in the range from 1-10 keV. Several fluorescence lines of different samples have been resolved, and for first time the line resolution have been measured and analyzed. We achieved a FWHM of 232 eV at 6.4 keV, and we concluded that incomplete charge collection (ICC) of the charge produced by the X-ray contributes to the resolution, being this effect more important at higher X-ray energies. The results analyzed in this work indicate that the mentioned CIS are specially suitable for X-ray applications in which energy and spatial resolutions are simultaneously required.

Keywords: X-rays spectroscopy, CMOS image sensors (CIS), CMOS Active Pixel Sensor (APS), Front-side illuminated, charge transport, single-photon, Incomplete Charge Collection (ICC), Charge Collection Efficiency (CCE).

2010 MSC: 00-01, 99-00

1. Introduction

Since their discovery in 1895 by Roentgen, X-rays have found a countless number of everyday applications in medicine, industry, and have been a powerful tool in material science and biology. Common technologies for their detection and energy measurement, are silicon drift detectors (SDD) and ad hoc detectors. In the field of big area X-ray radiography, due to their low cost compared to thousand of dollars flat panels, radiographic films still been the preferred option.

Nowadays CMOS image sensors (CIS) can be found in several consumer electronics products, like picture cameras and cell phones. They are mass-produced, have a low cost, and thanks to the integration in the same chip of the analog and digital reading electronics, can be easily integrated in embedded systems. In the last two decades, they have been used as charged particles and gamma photons detectors. For example in high resolution X-ray transmission imaging of small objects (Lane, 2012) (Hoidn and Seidler, 2015) (Castoldi et al., 2015) (Alcalde Bessia et al., 2018). Also, previous works have demonstrated the potential of these sensors for X-ray spectroscopy without analyzing the resolution capabilities of this devices (Lane, 2012) (Hoidn and Seidler, 2015) (Holden et al.,

2018) (Nachtrab et al., 2009), which is the main objective of this work.

In Section 2 we present a brief overview of CIS physics, from the interaction of the X-rays with the silicon to the collection of charge in the pixels, which is necessary to interpret the experimental results introduced in this work. In Section 3 we will describe the employed sensor and the image processing technique followed to detect the X-ray lines emitted from the fluorescence of different materials. The response of the CIS at different X-ray energies, as well as the experimentally obtained energy resolution are shown in Section 4. Finally, in Section 5, the read-out noise, energy resolution, dynamic range and efficiency of the detector will be analyzed.

2. X-ray spectroscopy with CIS

The most probable interaction mechanism of soft X-rays with silicon is the photoelectric effect, in which one atomic electron of the silicon absorbs the total energy of the incoming photon. The K-shell electrons, because of their proximity to the Silicon nucleus, have the highest probability of interacting with the photons (Gruppen and Schwartz, 2008). When this interaction occurs, the K-shell electron is ejected from the Si atom with a kinetic energy $E_x - E_b$, where E_x is the energy of the X-ray and E_b is the binding energy for K-shell electrons. The electron produced, called photo-electron, is emitted in a wide angular range, being the most probable emission normal to that of the incoming the photon (Watson, 1928). This ejected electron produces

*Fully documented templates are available in the elsarticle package on CTAN.

*Corresponding author

Email address: miguelsofoharo@gmail.com (Miguel Sofo Haro)

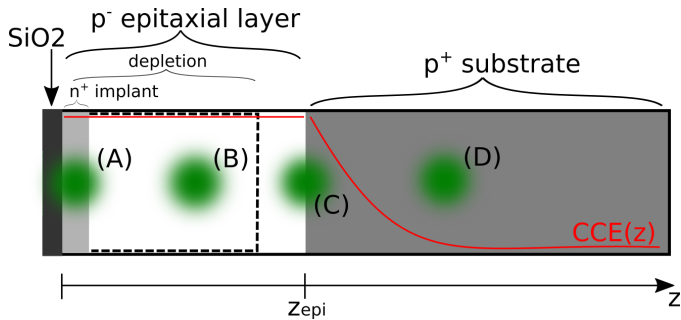


Figure 1: Transversal section of a CIS pixel. The green clouds represents the charge produced by an X-ray interacting at different regions of the pixel. The curve in red, is the charge collection efficiency (CCE). In the epitaxial layer the CCE is maximum, and in the substrate, it falls exponentially.

an ionization trail of electron-hole pairs (e-h) through inelastic collisions with orbital electrons of the other silicon atoms. The K-shell vacancy could be filled by two mechanisms (Janesick, 2001). The mechanism with higher probability is the Auger process, in where the electrons from outer shells drop to inner ones as a free electron is ejected from the atom, thus producing a subsequent ionization (Janesick, 2001). The second, is the drop of an outer-shell electron to the K-shell generating a characteristic photon of ~ 1.78 keV for Silicon. This photon can escape from the detector or interact in the same or other pixel generating ~ 481 e-h pairs, producing a double event. All the released e-h pairs by the photo-electron and the Auger effect, on average will be distributed in a charge cloud with a Gaussian profile. The deviation σ_I of the profile is given by $0.257R_{e^-}$ (Yousef, 2011), where R_{e^-} is the range of the photo-electron that can be obtained from equation 1 (E_{e^-} in keV) (Yousef, 2011). As an example, an electron of 10 keV will produce its ionization in a cloud of radius $\sim 0.25 \mu\text{m}$ (Williams, 2001) (Ashley et al., 1976) (Moody et al., 2017).

$$R_{e^-}(\mu\text{m}) = 0.0171E_{e^-}^{1.75} \quad (1)$$

The ionization produced by the photo-electron is a random process, therefore a finite and random fraction of the X-ray energy is transferred to the silicon in non-e-h processes (e.g, thermal excitation) (Janesick, 2001). The average number and variance are given by E_x/ω and FE_x/ω respectively (Janesick, 2001,F), where ω is the mean energy required to liberate one e-h pair. In silicon, at room temperatures (300 K), ω is equal to 3.62 eV (Groom et al., 2004,O). The constant F is called Fano Factor and its value is approximately ~ 0.115 (Janesick, 2001,F).

Standard CIS are fabricated over a heavily doped p-type thick substrate (p_{sub}^{++} , $> \sim 300 \mu\text{m}$ thick). Over it, a light-doped silicon epitaxial layer is grown (p_{epi}^-). Within the epitaxial layer n-type well structures are implanted (n_{well}^+), to form the $n_{\text{well}}^+/p_{\text{epi}}^-$ diode junctions ($\sim 1 \mu\text{m}$ thick) that are the charge collection element of each CIS pixel (Meroli et al., 2011) (Meroli et al., 2012) (Esposito et al., 2017). Figure 1 shows a schema of the transversal section of a CIS pixel.

The amount of collected charge will change depending in which region of the CIS it was generated. This effect has been

previously observed and measured using high energy protons and electrons (Meroli et al., 2011) (Meroli et al., 2012), and simulated in (Esposito et al., 2017).

If the charge is generated inside the depleted region of the collection diode, all the charge will be collected. In field-free regions, like the epitaxial layer, the charge is transported to the collection diodes through a thermal diffusion process. Therefore it can be spread over neighboring pixels. The barrier introduced by the junction between the epitaxial layer and the substrate limits the charge diffusion towards the substrate (Esposito et al., 2017). In the previous region all the charge is collected, and therefore charge collection efficiency (CCE) is maximum. If the charge is generated in the substrate, it is also transported to the collection diodes through diffusion. Due to the high doping of this region and the distance to the collection diodes, the recombination losses are higher (Schroder, 1997), incurring in what is called in the bibliography as incomplete charge collection (ICC) losses. In this last case, the CCE falls exponentially. For example, for a CIS MT9V011, the CCE goes below 80% beyond $2 \mu\text{m}$ of the epitaxial layer (Meroli et al., 2012).

Depending in which region of the CIS the X-ray interacts, will be the amount of collected charge. The charge cloud produced by an X-ray could be, in the epitaxial layer near the silicon oxide (case (A) of Figure 1), totally in the epitaxial layer (case (B)), in the substrate (case (D)) or in an intermediate case, in where it is partially in the epitaxial layer and in the substrate (case (C)). In the case (A), part of the generated charge will be trapped in the silicon oxide, this effect have been previously characterized in CCDs (Prigozhin, 2000). In the cases (C) and (D), only a fraction of the charge will be collected, and the remaining fraction will be lost by recombination. For a certain X-ray energy, the final energy spectrum will be composed of events that had interacted in these four regions. If the X-rays have low energy, they will interact in the first few microns of the CIS in where the CCE is higher, and the spectrum will be composed mostly by events without ICC. For higher energy X-rays, they will interact more deep in the CIS, reaching the substrate and also producing a bigger charge cloud, and therefore events with ICC will be collected widening the peak shape. The final peak shape, will depends on the amount of X-rays that interacted in each region of the CIS.

3. Experimental method

An MT9M001 CIS manufactured by On Semiconductors was chosen for this work (ONSEMI). It is a front-illuminated monochrome image sensor with 1280×1024 pixels of $5.2 \times 5.2 \mu\text{m}^2$ each one, covering a total area of $6.66 \times 5.32 \text{mm}^2$. A previous work in our group estimated the epitaxial layer thickness in $\sim 2 \mu\text{m}$ (Bessia et al., 2018), together with its pixel size, a good spectral resolution is expected. In this work, the pixel voltage was read using with the internal 10-bit analog to digital converter (ADC). A previous demonstration of the X-ray spectroscopy capabilities of this sensor can be found in (Hoidn and Seidler, 2015). A custom printed circuit board was designed to operate the sensor and provide extra passive components, like

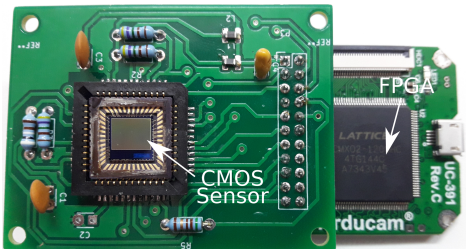


Figure 2: Picture of the detector electronics. The CIS is installed in a custom PCB. The sensor read-out and data transfer to the PC, through a USB interface, is done by an FPGA-based board developed by the company Arducam (Arducam).

power supply filtering and pull-up resistors. The custom board is connected to a board developed by the company Arducam (Arducam). It is an open hardware and software FPGA-based board that does the read-out of the CIS and transfers the data to a computer by an USB interface. A image of the whole system is shown in Figure 2. To avoid X-ray attenuation, the protective glass that covers the CIS was removed, and to shield it against light, a $130\ \mu\text{m}$ thick layer of aluminum was used. The whole system was operated at room temperature without temperature control.

The rolling shutter of the MT9M001 was set in one hundred lines. This makes possible integrate simultaneously one hundred lines of pixels, given a pixel integration time of 6.3 ms (ONsemi). The automatic black level calibration was disabled to avoid adding artifacts to the pixel value.

An X-ray tube with a copper target, model KFF-Cu-4K from Siemens, was used as source. The sensor was not only exposed to the beam photons, the Cu K-lines were also employed to produce fluorescence photons from two samples, thus exposing the sensor to different X-rays lines. The first sample was an iron metal foil, and the second one, a seashell. The current and voltage of the tube and the distance to the sensor were adjusted to have an appropriate X-ray flux to avoid pile-up of events in the image and mainly detect single-photon interaction in the sensor. Figure 3 is a region of an image captured with the sensor, in which each group of bright pixels is produced by a single interactions of one X-ray.

The pixel offset and gain can be controlled in the MT9M001 CIS. Each group of pixels with same column and row parity have a common variable to control the offset and another variable for the gain. The gain of all the pixels was set at its maximum value of $\times 15$. The offset was adjusted to sample the full pixel noise distribution. Figure 4a shows a plot of the single-pixel distribution of a dark frame (without X-rays). A group of pixel is centered around ~ 55 ADU and the other around ~ 90 ADU. To remove the bias of each pixel (in order to apply a common threshold during the extraction of X-ray events), the mean of the previous fifteen acquisition of the pixel was subtracted. The resulting pixel distribution is shown in Figure 4b. It is Gaussian distribution with zero mean and a standard deviation $\sigma \sim 3.11$ ADU. This deviation depends on the electronic read-out noise and thermal generation of carriers, in the following, we will refer to this value as image noise.

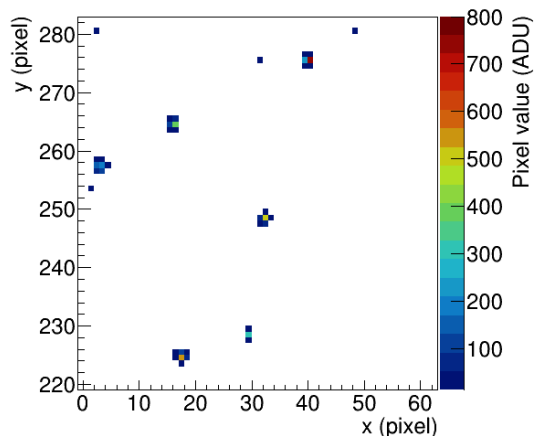


Figure 3: Example of an image region captured with the CIS. Cluster of pixels that correspond to single X-ray photons interactions can be observed. The white color was assigned to pixels with less than four times the image noise.

4. Measurement of the X-ray spectrum

To extract the cluster of pixel that correspond to an X-ray interaction, we applied the same method used in CCD particle detection experiments (Chavarría et al., 2015). First, seeds of single or neighboring pixels that have a value more than four times the image noise, this is 4σ , are identified in the acquired frame. Then, all the pixels around the event seed with more than 3σ are added to form a cluster of pixels that compose the event. The charge of the event is obtained adding all the values of its pixels.

The energy spectrum measured with the CIS exposed to the copper X-rays tube, and to the fluorescence from the metal foil and the seashell, are shown in Figures 5,6 and 7 respectively. The spectrum in black is obtained using all the extracted events. As was formerly exposed in section 2, unless the event occurs in the depleted region of the collection diodes, there will be charge losses due to recombination. This can be observed comparing the spectrums of events with two and one pixels of Figure 5. For the Cu K_{α} line, the peak produced by events with signal at two pixels is shifted to the right and wider with respect to that due to events with signal in only one pixel. Therefore, the measured charge of events with several pixel underestimates the intensity due to the incomplete charge collection (ICC) formerly described. For this reason, to improve the spectral resolution, an additional cut over the events of only one pixel was implemented. Single pixel events, that have at least in one of the eight closest neighboring pixels, a value more than one sigma of the image noise, were discarded. As shown in the Figures 5,6 and 7, a better resolution is obtained rejecting events with more than one pixel, thus allowing to resolve several X-ray lines.

The spectrum of Figure 5 shows that the K_{α} and K_{β} lines from copper can be resolved, as well as the K_{α} and K_{β} lines from the fluorescence of Titanium present in the stainless steel of the X-ray tube. The copper K_{α} escape line corresponds to an interaction in which a fraction of the energy was firstly deposited and then, as was explained in Section 2, a subsequent

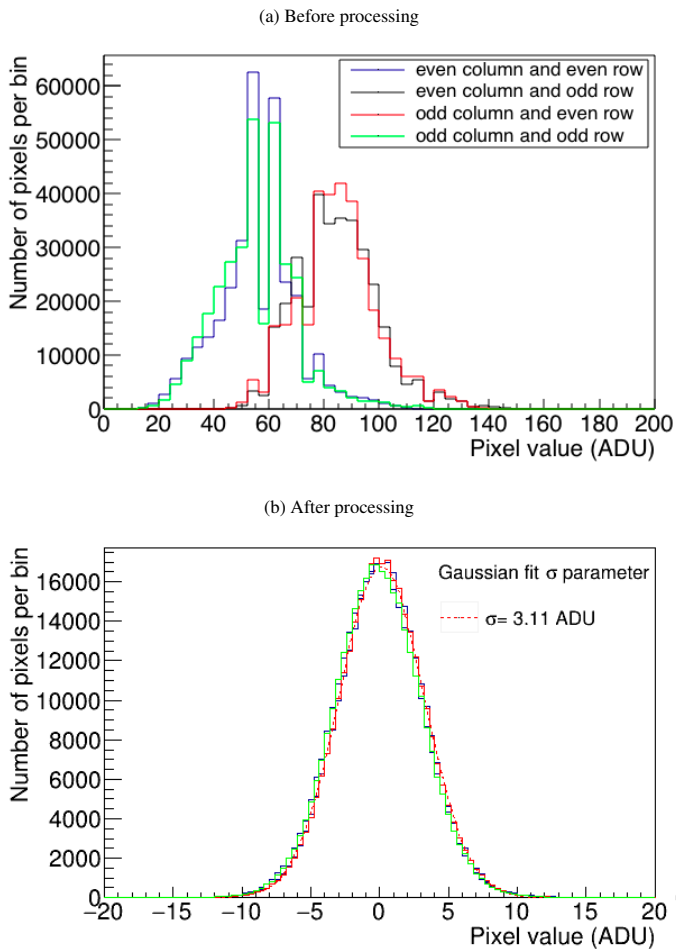


Figure 4: Single pixel distribution of a dark frame before (4a) and after processing (4b). A Gaussian fit of the distribution of pixel in odd columns and even rows is included, it has a σ of 3.11 ADU, we will refer to this value as image noise.

silicon K_{α} photon is emitted that could interact in another pixel and produce the line that is seen in the spectrum.

The counts observed at about ~ 950 ADU in Figures 5, 6 and 7, are produced by events that saturate the ADC. The particular shape is introduced by the pixel bias subtraction method, see Figure 4.

A Gaussian distribution was used to fit each one of the peak. The fits of the peaks from the fluorescence of copper, iron, silicon and calcium are shown in Figures 8 and 9, 10 and 11 respectively. For the case of iron, a background subtraction was applied. The background was estimated from the direct exposure of the CIS to the X-ray tube (spectrum of Figure 5). The resulting spectrum is shown in Figure 9.

5. Results

5.1. Gain and Noise

Correlating the energy of the X-ray and the obtained μ parameter, a calibration factor of 90.3 ADU/keV was obtained.

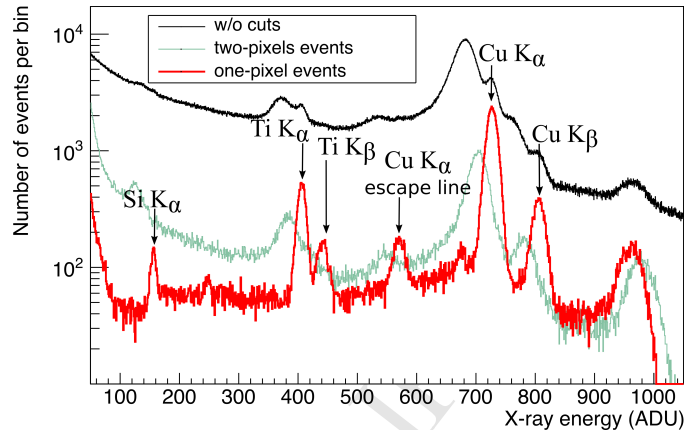


Figure 5: Spectra obtained by different processing methods, exposing the CIS directly to the X-rays from the tube.

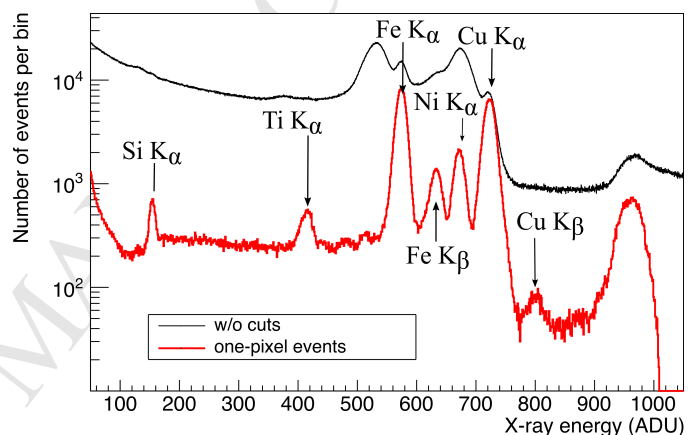


Figure 6: X-ray spectrum obtained from the fluorescence of a metal foil. The iron K_{α} and K_{β} lines can be resolved, as well as the K_{α} line from nickel.

The resulting fit is shown in Figure 12, where a high linearity in the measurement of the X-ray energy is observed.

Taking in account that ~ 3.64 eV are required in average to generate an electron-hole pair in silicon, the 90.3 ADU/keV conversion gain imply that each ADU corresponds to 3.04 electrons in our configuration with an analog gain of $\times 15$. Considering the pixel saturation of 1.2 V, this implies a conversion gain of the sensor of $22.5 \mu\text{V}/e^{-}$, which differs only with the nominal conversion gain of $32 \mu\text{V}/e^{-}$ reported by the manufacturer (ONSem) in a 30% consistent with fabrication process variations in typical submicron CMOS technologies.

Using the previous calibration factor an image noise of 34.4 eV ($\sim 9.4 e^{-}$) was obtained. It corresponds to the standard deviation of the distribution of Figure 4b, which is consistent with the value reported by the manufacturer of lower than $10 e^{-}$ (ONSem). In a CIS the electronics associated to each pixel is different and therefore will also have different read-out noise. This was analyzed taking 1000 dark frames and calculating the standard deviation of the distribution of the values for each pixel. The result is shown in Figure 13, the 90% of the pixels have less than $\sim 10 e^{-}$ of noise.

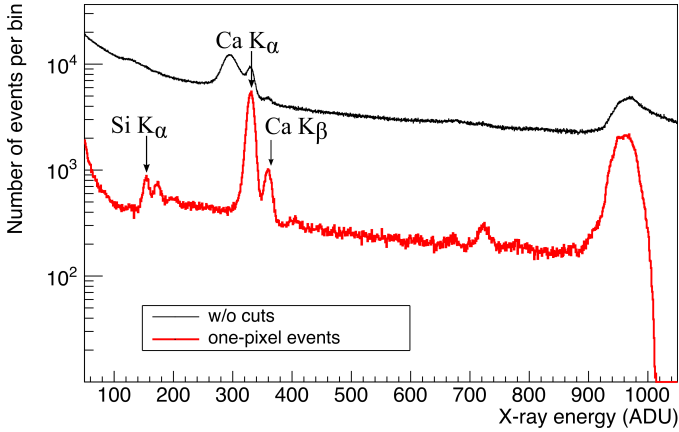


Figure 7: X-ray spectrum obtained from the fluorescence of a seashell. The calcium K_α and K_β lines are resolved.

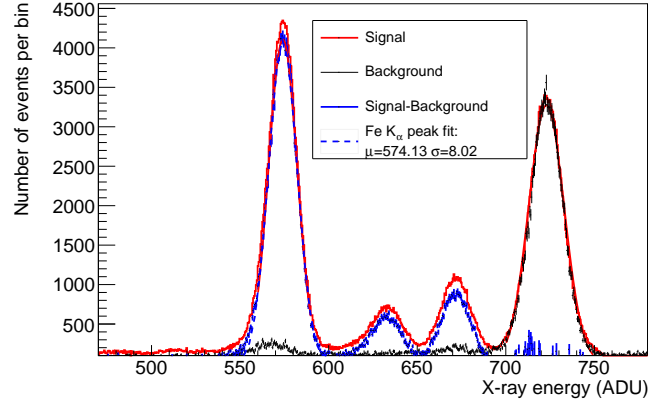


Figure 9: Fit of the K_α fluorescence peak from the iron of the metal foil.

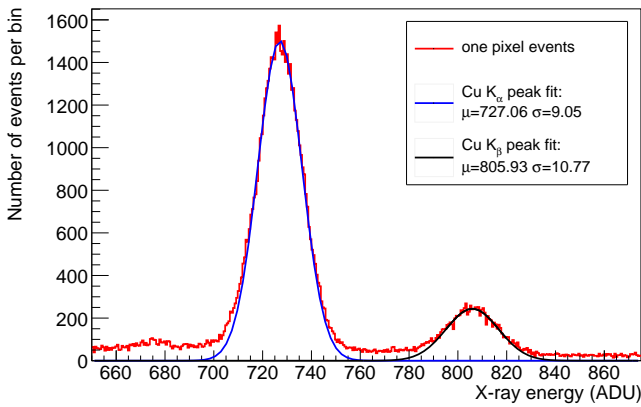


Figure 8: Fit of fluorescence peaks from copper.

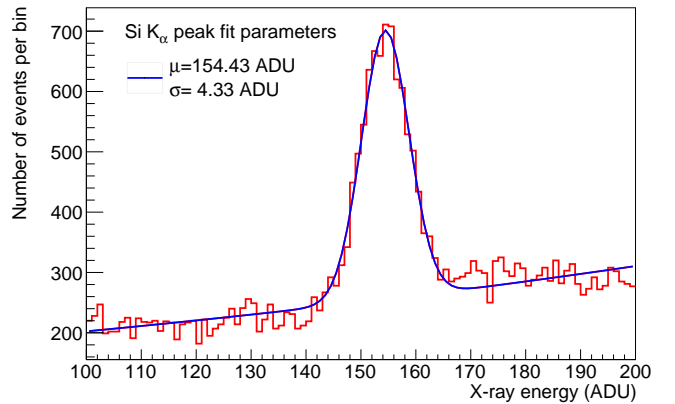


Figure 10: Fit of the K_α peak from silicon fluorescence. A Gaussian distribution for the peak shape over an exponential background, was fitted to obtain the peak parameters.

5.2. Resolution

Table (1) is a summary of the resolution measured of each peak with the MT9M001 CIS. They were obtained multiplying the σ parameter of the Gaussian fit of each peak by the calibration factor of 90.3 ADU/keV.

Figure 14 shows the resolution obtained from the peak with experimentally observed, as well as the Fano, and the electronic readout contribution. As was expected, ICC deteriorate the spectroscopic resolution, and it is mostly degraded at higher energies. For the peak produced by the Si K_α line, the range of the emitted photo-electron is $0.04\ \mu\text{m}$, significantly smaller than the device sensitive thickness ($\sim 2\ \mu\text{m}$). For this energy,

Peak	Energy (keV)	σ (eV)
Cu K_β	8.90	118.1 ± 3.8
Cu K_α	8.04	99.3 ± 1.5
Fe K_α	6.40	88.0 ± 0.3
Ti K_α	4.51	74.4 ± 1.0
Ca K_α	3.70	67.3 ± 0.27
Si K_α	1.74	47.5 ± 1.2

Table 1: Measured resolution of each X-ray line.

events whit charge losses are less probable that at higher energies, and therefore the resolution is mostly dominated by the read-out noise and Fano contribution.

5.3. Dynamic range

Considering the event extraction method developed in this work, that basically consist on extract only single-pixel events with value more than four times the image noise of 33.5 eV, the minimum observable energy is approximately 136 eV. Taking into account the operation conditions of the MT9M001 described in Section 3, that require a maximum gain as well as to sample the mean value of each pixel, and the dynamic range of the ADC of 1024 ADU, the maximum observable energy is less than 10 keV.

5.4. Quantum efficiency

Although the achieved energy resolution with the CIS is promising and allows to resolve different energy peaks, a low intrinsic quantum efficiency is expected. The MT9M001 microlenses and the metal layers that connect the different chip components produce an attenuation of the incoming X-rays (Bessia et al., 2018). Furthermore, a significant reduction in efficiency is due to the poor depletion volume, which has been estimated

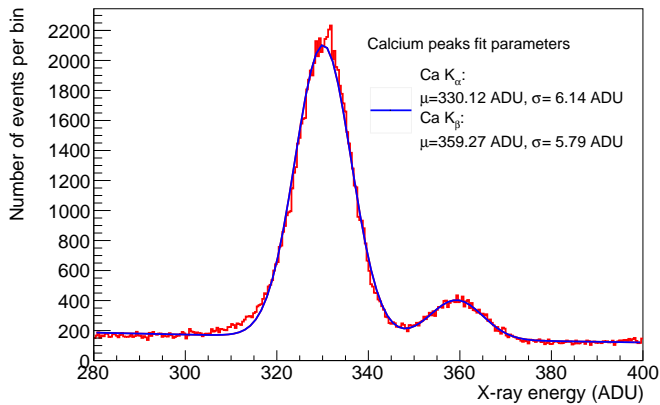


Figure 11: Fit of K_α and K_β peak from calcium fluorescence. The sum of two Gaussian distribution plus an exponential background was fitted with the spectrum data to extract the peaks parameters.

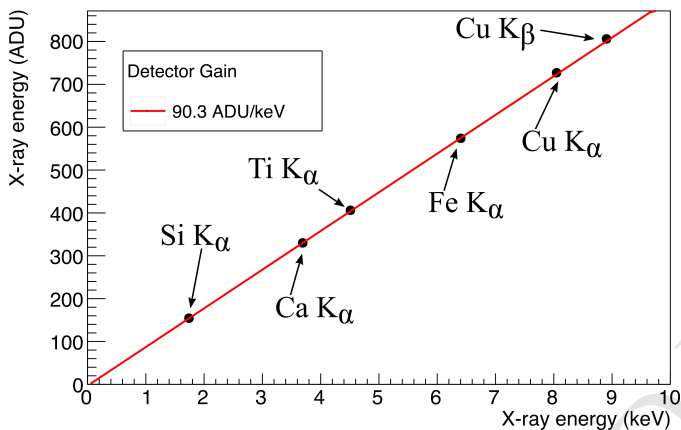


Figure 12: CIS calibration curve. The CIS shows a linear response in the X-ray energy range measured. The experimental uncertainties of the results are smaller than the symbol size.

to be $14\mu\text{m}^3$ for the MT9M001 (Bessia et al., 2018), that correspond a sensitive thickness of $\sim 1.9\mu\text{m}$.

5.5. Comparison with a SDD

In this work a FWHM of 231.8 eV at 6.4 keV was achieved with the MT9M001 CIS. For example, the well established AMPTEK XR-100 Silicon Drift Detector (SDD) (Amptek) used in X-ray spectroscopy, which operates 85°C below ambient temperature has a FWHM of 122 eV at 5.9 keV and a read-out noise of $4.5 e^-$; only a half of the value reported in this paper for an uncooled, low cost device which can be easily integrated in an embedded system. The disadvantage of the commercial CIS are the smaller sensitive thickness of $1\text{-}2\mu\text{m}$ (Meroli et al., 2012) (Bessia et al., 2018), thinner than the attenuation length of the X-ray photons, which reduces the detection efficiency compared to the $500\mu\text{m}$ thick SSD. However, the pixelated nature of the CIS, combined with the ability of measuring photon energy demonstrated in this work allows potential applications in energy sensitive X-ray imaging where an SDD cannot be used.

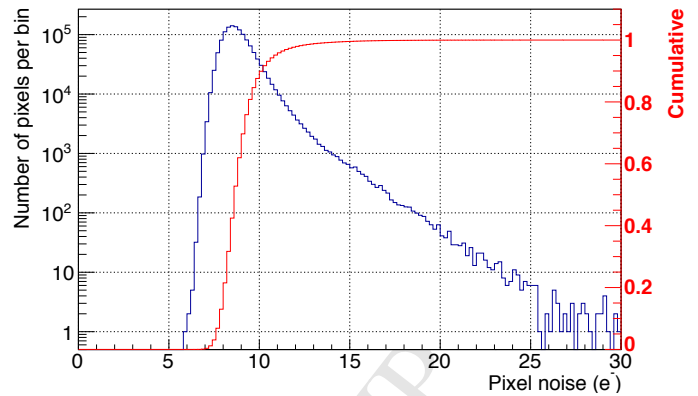


Figure 13: Distribution of the pixels noise. The 90% of the pixels have less than $\sim 10 e^-$ of noise.

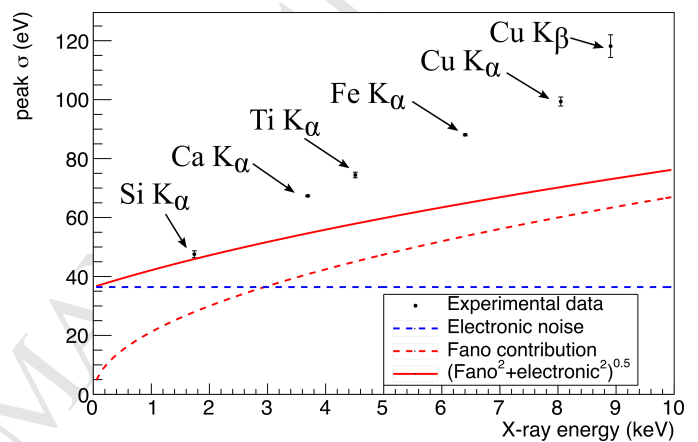


Figure 14: Peak resolution measured with the MT9M001. A Fano factor of 0.1254 measured at room temperature was used (Perotti, 1999).

6. Conclusions

We have demonstrated the capability of a commercial and low cost CIS to resolve several X-rays peaks in the range from $\sim 1.7\text{-}9\text{ keV}$, without cooling the detector. For first time the energy resolution of this devices was measured and analyzed for soft X-rays. The contribution of the read-out noise, Fano noise and ICC, to the resolution was studied, being the ICC the dominant factor at higher energies. A resolution comparable to a professional SDD was obtained. CIS are therefore a valid option as low cost and easy access X-ray detector, for example, for educational purposes. Besides, the possibility of combining high resolution X-ray imaging and spectroscopy in a single-device could allow CIS to be used as the replacements of more expensive detection technologies in several biological and material sciences applications.

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Highlights

- X-ray spectroscopy at room temperature with a CIS up to 10keV.
- Configuration and operation of MT9M001 is described.
- Image processing and event selection criteria were developed to have high resolution.
- For first time X-ray lines resolution have been measured and analyzed.
- Incomplete charge collection (ICC) contributes to the resolution.